

Substitute for forms 1449A/PTO &amp; 1449B/PTO

# **FIRST INFORMATION DISCLOSURE STATEMENT BY APPLICANT**

ATTORNEY'S DKT NO.  
007413-060

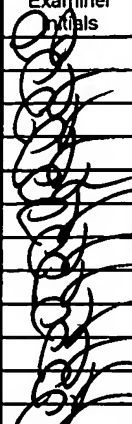
APPLICATION NO.  
10/631,900

APPLICANT  
Wilfried CLAUSS

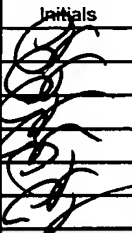
FILING DATE  
August 1, 2003

GROUP  
Unassigned


## **U.S. PATENT DOCUMENTS**

Examiner Initials	Document Number	Kind Code (if known)	Name of Patentee or Applicant of Cited Document	Issue/Publication Date (MM-DD-YYYY)
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	4,376,249		Pfeiffer et al.	03-08-1983
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	5,629,526		Nakasuji	05-13-1997
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	2002/0084422	A1	Kienzle et al.	07-04-2002
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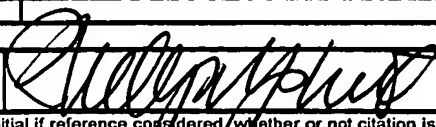
## **FOREIGN PATENT DOCUMENTS**

Examiner Initials	Document Number	Kind Code (if known)	Country	Date of Publication (MM-DD-YYYY)	Translation Yes No
	0 461 366	A2	Europe	12-18-1991	
	100 44 199	A1	Germany	06-06-2002	X
	64-017364	A	Japan	01-20-1989	Abst
	2001230190	A	Japan	08-24-2001	X
	2002170761	A	Japan	06-14-2002	X
	2001307975	A	Japan	11-02-2001	X

## **NON PATENT LITERATURE DOCUMENTS**

Examiner Initials	Include name of author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.
	X. ZHU et al., "Comprehensive Analysis of Electron Optical Design of SCALPEL-HT/Alpha", Proc. SPIE, Vol. 3997, pp. 170-183, July 2000, Emerging Lithographic Technologies IV, Elizabeth A. Dobisz, Ed.
	Eiichi GOTO et al., "MOL (moving objective lens) Formulation of defective aberration free system," OPTIK, Vol.48, No. 3, pp. 255-270 (1977), Wissenschaftliche Verlagsgesellschaft mbH, Stuttgart, Germany.

Examiner  
Signature



Date  
Considered

3-31-2004

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